Diffraction User Center Instruments

High-Temperature X-ray Diffractometer

High-Temperature Neutron Powder Diffractometer

Synchrotron Powder Diffractometer (Room Temp & High Temp)

Room-Temperature X-ray Diffractometers

Software and Data Processing

Philips X'Pert Pro MPD X-Ray Diffractometer with Anton PAAR XRK-900 High Temperature Stage

Low Temperature X-ray Diffractometer

Thermophysical Properties User Center Instruments

Thermal Analysis Instruments:

Simultaneous Thermal Analysis/Mass Spectrometer (DTA/TG/MS to 1500°C)

Concurrent Thermal Analysis (TG/DTA to 1700°C)

Differential Scanning Calorimeter (DSC to 1500°C)

Dual Push Rod Dilatometer (CTE to 1600°C)

Vertical Dilatometer (CTE to 2400°C and bi-layer CTE to 1600°C)

Auto Pycnometer (density at RT)

Thermal Transport Instruments:

High-Temperature Laser Flash Thermal Diffusivity System (LFTD to 2500°C)

Room-Temperature Xenon Flash Thermal Diffusivity Unit

Infrared Camera

3-Omega Thermal Conductivity System

Hot Disk Thermal Constants Analyzer

Residual Stress User Center Instruments

X-Ray Diffraction Facilities Overview

4-Axis Goniometer/18-kW Rotating Anode X-ray Source

4-Axis Goniometer/2-kW X-ray Tube

X14A Synchrotron 6-Axis Goniometer

Large Specimen X-ray Residual Stress Mapping Facility

Philips X'Pert Pro MPD X-Ray Diffractometer with Anton PAAR XRK-900 High Temperature Stage Neutron Diffraction Facilities Overview

Second Generation Neutron Diffraction Residual Stress Mapping Facility (NRSF2)

Mechanical Characterization & Analysis User Center Instruments

High-Temperature Tensile Test Facility

Tensile Creep/Stress Rupture and Stress Relaxation Facility

Ceramic Flexure Test Facility

Electromechanical Test Facility

Electromechanical Test Facilities with Environmental Testing

Test Facility for Composites and their Constituents

Mechanical Properties Microprobe

Life-Prediction Analysis (FEA + ERICA / CERAMIC + CARES)

Resonant Ultrasound Spectroscopy (RUS) Facility

Materials Analysis User Center Instruments

Transmission Electron Microscopy

Hitachi HF-2000

Aberration Corrected Electron MicrosopeACEM, based on JEOL 2200FEF-AC

Dedicated Scanning Transmission Electron Microscope

Hitachi HD-2000 STEM

Scanning Electron Microscopes

Hitachi S-4700 & S-800

Scanning Auger Microprobe

PHI 680 Scanning Auger Microprobe

Electron Probe Analysis

JEOL 8200 Electron Superprobe

Focused Ion Beam Micromill

Hitachi FB-2000 FIB

Friction, Wear & Machinability User Center Instruments

Machining Instruments

K. O. Lee Instrumented Creep Feed Grinder

Weldon Cylindrical Grinder

Nicco Creep Feed Surface Grinder

Sabre CNC Vertical Grinding Center

Benchman® VMC4000 Vertical Machining Center

Compact Grindability Test System

proLIGHT™ 3000 Turning Center

Inspection Instruments

Electronic Measuring Devices (EMD) Legend Integrated Metrology Center

Taylor Hobson Form Talysurf 120 Stylus Profiler

Rodenstock Surface Topography Measurement System

Mahr MMQ40 Formtester

KSI SAM-2000 Scanning Acoustic Microscope

Nikon Model V-12 Profile Projector

Tribology Instruments

Pin-on-disk Friction and Wear Testing Stations

Reciprocating Friction and Wear Tester

Repetitive Impact Testing System

Cameron-Plint Model TE-77 Reciprocating Sliding Wear Tester

Microfriction Apparatus

CSEM Instrumented Scratch Tester

High-Temperature Pin-on-disk System

Cameron-Plint TE-53 Multi-mode Rolling/Sliding Friction and Wear Tester

Micro-Abrasive Wear Testing Machine

Sub-Scale Brake Material Testing System

Sather High-Temperature Oscillatory Scuffing Tester Capacity Screening Rig

Teledyne-Taber Portable Scratch Tester

Wilson Microindentation Hardness Tester

Talysurf Model 10 Stylus Surface Roughness Measuring System

Durometer for Measuring Elastomer Hardness